

10/501310
 DTG 13 JUL 2004

| | | |
|--|----------------------------------|--------------------------------|
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT | ATTY. DOCKET NO. 10901/81 | SERIAL NO. Not Yet Assigned |
| | APPLICANT Roman WOYZICHKOVSKI | |
| | FILING DATE Herewith | GROUP To be assigned |

U. S. PATENT DOCUMENTS

| EXAMINER INITIAL | PATENT NUMBER | PATENT DATE | NAME | CLASS | SUBCLASS | FILING DATE* |
|---------------------|------------------|------------------|-------------------|-------|----------|-----------------|
| /J.P./ | 5,644,514** | July 1, 1997 | Mitsuyoshi et al. | | | |
| /J.P./ | 5,220,275* | June 15, 1993 | Holmovist | | | |
| /J.P./ | 5,677,686* | October 14, 1997 | Aoki et al. | | | |
| /J.P./ | 5,783,925** | July 21, 1997 | Wise | | | |
| /J.P./ | 5,963,160** | October 5, 1999 | Wilson et al. | | | |
| /J.P./ | 5,920,494** | July 6, 1999 | Setbacken et al. | | | |
| | 5,734,688** | March 31, 1998 | Teraguchi et al. | | | |
| /J.P./ | 5,485,152** | January 16, 1996 | Wilson et al. | | | |
| /J.P./ | 5,142,226** | August 25, 1992 | Sakamoto et al. | | | |
| | | | | | | |
| | | | | | | |

* - copy of reference not enclosed, cited in International Search Report and copy provided by searching authority.

** - copy not provided pursuant to Official Gazette Notice dated August 5, 2003.

FOREIGN PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
|---------------------|--------------------|-------------------|---------|-------|----------|-------------|----|
| | | | | | | YES | NO |
| | 199 38 802*** | February 22, 2001 | DE | | | | |
| | 0 875 735*** | November 4, 1998 | EP | | | | |
| | 198 22 843 | November 25, 1999 | DE | | | | |
| | 100 25 160 | December 6, 2001 | DE | | | | |
| | 199 34 478 | February 8, 2001 | DE | | | | |
| | 0 484 576 | May 13, 1992 | EP | | | | |
| | 0 997 701 | May 3, 2000 | EP | | | | |
| | 195 02 276 | August 1, 1996 | DE | | | | |
| | 0 874 223 | October 28, 1998 | EP | | | | |
| | 0 669 517 | August 30, 1995 | EP | | | | |
| | 0 599 175 | June 1, 1994 | EP | | | | |
| /J.P./ | 195 06 276** | September 5, 1996 | DE | | | | |
| /J.P./ | 199 11 822*** | August 24, 2000 | DE | | | | |
| /J.P./ | 196 05 472*** | March 8, 2001 | DE | | | | |

| EXAMINER INITIAL | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
|---------------------|--------------------|--------------------|---------|-------|----------|-------------|----|
| | | | | | | YES | NO |
| /J.P./ | 195 44 948*** | September 26, 2002 | DE | | | | |
| /J.P./ | 0 724 137 | July 18, 2001 | EP | | | | |
| /J.P./ | 0 711 974 | September 26, 2001 | EP | | | | |
| /J.P./ | 197 04 132*** | August 7, 1997 | DE | | | | |
| | | | | | | | |
| | | | | | | | |

* - Copy of reference not enclosed, cited in International Search Report and copy provided by searching authority.

** - Mentioned in the specification.

*** - English-language abstract included herewith.

OTHER DOCUMENTS

| EXAMINER INITIAL | AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC. |
|---------------------|---|
| | M. Peuker, "Optimum energy for high resolution low voltage electron beam lithography - Monte Carlo simulations and experiments", Microelectronic Engineering, , Bd. 53, Nr. 1-4, June 2000, pp. 337-340." |

** copy of reference not enclosed, cited in International Search Report and copy provided by searching authority.

| | | | |
|---|-----------------|-----------------|------------|
| EXAMINER | /Jason Perilla/ | DATE CONSIDERED | 07/17/2007 |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | | | |



| | | |
|--|----------------------------------|--------------------------|
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT | ATTY. DOCKET NO. 10901/81 | SERIAL NO. 10/501,310 |
| | APPLICANT Roman WOYZICHKOVSKI | |
| | FILING DATE Nov. 23, 2004 | GROUP To be assigned |

U. S. PATENT DOCUMENTS

| EXAMINER INITIAL | PATENT NUMBER | PATENT DATE | NAME | CLASS | SUBCLASS | FILING DATE* |
|---------------------|------------------|----------------|------------------|-------|----------|-----------------|
| /J.P./ | 5,706,219 * | Jan. 16, 1998 | Ishimoto | | | |
| /J.P./ | 5,999,113 * | Dec. 7, 1999 | Kiriyama et al. | | | |
| /J.P./ | 6,534,969 * | Mar. 18, 2003 | Dietmayer | | | |
| /J.P./ | 6,188,341 * | Feb. 13, 2001 | Taniguchi et al. | | | |
| /J.P./ | 5,625,310 * | Apr. 29, 1997 | Takeishi | | | |
| /J.P./ | 5,485,407 * | Jan. 16, 1996 | Ishimoto et al. | | | |
| | | | | | | |
| | | | | | | |
| | | | | | | |
| | | | | | | |
| | | | | | | |

* - copy not provided pursuant to Official Gazette Notice dated August 5, 2003.

FOREIGN PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
|---------------------|--------------------|------|---------|-------|----------|-------------|----|
| | | | | | | YES | NO |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |

OTHER DOCUMENTS

| EXAMINER INITIAL | AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC. |
|---------------------|--|
| | |
| | |

| | |
|---|-------------------------------|
| EXAMINER /Jason Perilla/ | DATE CONSIDERED 07/17/2007 |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |